-	66	((system.ti. and(regulat\$3)) and(memory	USPAT;	2004/10/20 08:52
		with synchronous near dynamic)) and	US-PGPUB;	
[(((system.ti. and(regulat\$3)) and(memory	JPO	
		with synchronous near dynamic))		
		and(dynamic near random near access near		
		memory))		, ,
-	1	, , , , , , , , , , , , , , , , , , ,	USPAT;	2004/10/20 08:52
		first near polarity)) and(terminal\$1 with	US-PGPUB;	
		second near polarity)) and(motherboard))	JPO	
		and(chip)) and(memory)		
-	0	361/\$.ccls. and (((system.ti.	USPAT;	2004/10/20 08:53
		and(regulat\$3)) and(memory with	US-PGPUB;	
		synchronous near dynamic)) and	JPO	
		(((system.ti. and(regulat\$3)) and(memory		
		with synchronous near dynamic))		
		and (dynamic near random near access near		i i
		memory)))		
_	15	(((system.ti. and(regulat\$3)) and(memory	USPAT;	2004/10/20 09:12
		with synchronous near dynamic)) and	US-PGPUB;	
		(((system.ti. and(regulat\$3)) and(memory	JPO	
		with synchronous near dynamic))		
	1	and(dynamic near random near access near		
		memory))) and(capacitor)		l
-	671	electronic.ti. and (motherboard)	USPAT;	2004/10/20 09:13
			US-PGPUB;	
			JPO	
_	38	electronic.ti. and(motherboard))	USPAT;	2004/10/20 09:13
	ĺ	and(voltage near regulat\$3	US-PGPUB;	
			JPO	·
-	22	((electronic.ti. and(motherboard))	USPAT;	2004/10/20 09:13
		and(voltage near regulat\$3))	US-PGPUB;	
		and(capacitor)	JPO	
-	19	(((electronic.ti. and(motherboard))	USPAT;	2004/10/20 09:13
		and(voltage near regulat\$3))	US-PGPUB;	
		and(capacitor)) and(chip)	JPO	
_	15	1 ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' '	USPAT;	2004/10/20 09:14
		and(voltage near regulat\$3))	US-PGPUB;	
		and(capacitor)) and(chip)) and(memory)	JPO	
-	15		USPAT;	2004/10/20 09:15
		and(voltage near regulat\$3))	US-PGPUB;	
		<pre>and(capacitor)) and(chip)) and(memory))</pre>	JPO .	
1		and(bus)		
-	65	capacitor.ti. and(motherboard)	USPAT;	2004/10/20 09:15
			US-PGPUB;	
			JPO	
-	42	capacitor.ti. and(motherboard)) and(memory	USPAT;	2004/10/20 09:15
			US-PGPUB;	
			JPO	
-	40	((capacitor.ti. and(motherboard))	USPAT;	2004/10/20 09:15
		and(memory)) and(chip)	US-PGPUB;	
			JPO	
-	15	(((capacitor.ti. and(motherboard))	USPAT;	2004/10/20 09:52
		and(memory)) and(chip)) and(bus)	US-PGPUB;	
			JPO	
_	4	multilayer with capacitor.ti. and(pcb)	USPAT;	2004/10/20 10:29
			US-PGPUB;	
			JPO	
-	4047	memory with synchronous near dynamic near	USPAT;	2004/10/20 10:30
		random near access	US-PGPUB;	
			JPO	
_	760	system.ti. and (memory with synchronous	USPAT;	2004/10/20 10:30
		near dynamic near random near access)	US-PGPUB;	, , , , , , , , , , , , , , , , , , , ,
		•	JPO	
-	8	361/\$.ccls. and (system.ti. and (memory	USPAT;	2004/10/20 10:34
		with synchronous near dynamic near random	US-PGPUB;	=====
		near access))	JPO	
_	0	multilayer with capacitor.ti. and(SDRAM)	USPAT;	2004/10/20 10:34
		- 1	US-PGPUB;	, =0, 20 10.34
			JPO	
_	56	capacitor.ti. and(SDRAM)	USPAT;	2004/10/20 10:47
			US-PGPUB;	, -0, 20 10.4,
			JPO	
			· ····	

-	32	capacitor.ti. and (memory with SDRAM)	USPAT;	2004/10/20 14:16
1			US-PGPUB;	
1			JPO	1
-	105	cylindrical with capacitor.ti.	USPAT;	2004/10/20 14:17
			US-PGPUB;	
•			JPO	
-	15	cylindrical with capacitor.ti.)	USPAT;	2004/10/20 14:17
		and(terminal	US-PGPUB;	
			JPO	
-	18	cylindrical with capacitor.ti.)	USPAT;	2004/10/20 14:20
		and(terminal\$1	US-PGPUB;	
			JPO	
-	3	cylindrical with capacitor.ti.)	USPAT;	2004/10/20 16:52
1		and (polarity	US-PGPUB;	
	,	-	JPO	
-	1	"20020168510"	USPAT;	2004/10/21 07:27
			US-PGPUB;	
1			JPO	
-	5816	capacitor.ti. and(terminal)	USPAT;	2004/10/21 10:02
	1	·	US-PGPUB;	
			JPO	
-	18	capacitor.ti. and(terminal))	USPAT;	2004/10/21 07:37
		and(electrical near plate	US-PGPUB;	
			JPO	
_	1		USPAT	2004/10/21 07:32
_	1 1		USPAT	2004/10/21 07:32
_	1		USPAT	2004/10/21 07:32
<u>-</u>	1		USPAT	2004/10/21 07:32
1_	1		USPAT	2004/10/21 07:32
_	1		USPAT	2004/10/21 07:32
1_	1		USPAT	2004/10/21 07:32
1_	2	low with inductance with capacitor.ti.)	USPAT;	2004/10/21 07:32
,	_	and(central near terminal\$1	US-PGPUB;	2004/10/21 07.38
		and (central hear terminary)	JPO	
1_	54	low with inductance with capacitor.ti.	USPAT;	2004/10/21 07:39
-] 34	tow with inductance with capacitor.tr.	US-PGPUB;	2004/10/21 07:39
			JPO	[
	6957	capacitor.ti. and(terminal\$1)		2004/10/21 10:03
-	0937	(capacitor.tr. and (terminal)	USPAT;	2004/10/21 10:03
			US-PGPUB;	
	00		JPO	2004/10/21 10:27
-	92		USPAT;	2004/10/21 10:2/
		near foil	US-PGPUB;	
		and the same of th	JPO	0004/10/01 10 00
-	0	········	USPAT;	2004/10/21 10:28
		solder near ball\$1	US-PGPUB;	
			JPO	0004/10/01 10 00
-	0	wound with capacitor.ti.) and (solder near	USPAT;	2004/10/21 10:29
		ball\$1	US-PGPUB;	
	_		JPO	2004/10/01 10 05
-	2	wound with capacitor.ti.) and(ball\$1	USPAT;	2004/10/21 10:29
			US-PGPUB;	
	1	, , , , , , , , , , , , , , , , , , , ,	JPO	
-	98	wound with capacitor.ti.	USPAT;	2004/10/21 10:37
			US-PGPUB;	
	1		JPO	
-	13	liu adj tao.in.	USPAT;	2004/10/21 10:45
	1		US-PGPUB;	
	1		JPO	
-	149	361/301.5 and(capacitor)	USPAT;	2004/10/21 13:04
			US-PGPUB;	
			JPO	
-	25156	printed near wiring near board	USPAT;	2004/10/21 13:05
			US-PGPUB;	
			JPO	
] -	128	capacitor.ti. and printed near wiring near	USPAT;	2004/10/21 14:53
		board	US-PGPUB;	
			JPO	
-	0	micromachi\$3 with varactor.ti.	USPAT;	2004/10/21 14:54
			US-PGPUB;	
	<u> </u>		JPO	

-	0	micro near machin\$3 with varactor.ti.	USPAT; US-PGPUB;	2004/10/21 14:54
-	0	micromachin\$3 with varactor.ti.	JPO USPAT; US-PGPUB;	2004/10/21 15:32
_	1	varactor.ti. and(deflecting near beam)	JPO USPAT; US-PGPUB;	2004/10/21 15:26
_	27	varactor.ti. and(beam)	JPO USPAT; US-PGPUB; JPO	2004/10/21 15:26
-	1	varactor.ti. and(beam)) and(path near plate\$1	USPAT; US-PGPUB; JPO	2004/10/21 15:26
_	12	varactor.ti. and(beam)) and(plate\$1	USPAT; US-PGPUB; JPO	2004/10/21 15:26
_	5	((varactor.ti. and(beam)) and(plate\$1)) and(vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 15:27
-	1	micromachin\$3 with varactor\$1.ti.	USPAT; US-PGPUB; JPO	2004/10/21 15:33
_	130	wong near marvin.in.	USPAT; US-PGPUB; JPO	2004/10/21 16:08
-	1	6657525.pn.	USPAT; US-PGPUB; JPO	2004/10/21 16:14
_	7	MEMS.ti. and(deflecting near beam)	USPAT; US-PGPUB; JPO	2004/10/21 16:19
-	2	<pre>MEMS.ti. and(deflecting near beam)) and(plate\$1</pre>	USPAT; US-PGPUB; JPO	2004/10/21 16:19
_	0	((MEMS.ti. and(deflecting near beam)) and(plate\$1)) and(vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 16:19
_	0	((MEMS.ti. and(deflecting near beam)) and(plate\$1)) and(airtight near vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 16:20
-	0	MEMS.ti. and(airtight near vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 16:20
-	0	microelectrochemical.ti. and(airtight near vacuum)	USPAT; US-PGPUB; JPO	2004/10/22 08:49
-	1	varactor with airtight near vacuum	USPAT; US-PGPUB; JPO	2004/10/21 17:00
	7	"5978204"	USPAT; US-PGPUB; JPO	2004/10/21 16:49
_	477	mems.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/21 17:02
_	248	mems.ti. and(beam)) and(plate\$1	USPAT; US-PGPUB; JPO	2004/10/21 17:01
_	126	((mems.ti. and(beam)) and(plate\$1)) and(cantilever\$2)	USPAT; US-PGPUB; JPO	2004/10/21 17:02
_	27	varactor.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/21 17:03
_	0	<pre>varactor.ti. and(beam)) and(cantilever\$2</pre>	USPAT; US-PGPUB; JPO	2004/10/21 17:03
_	79	varactor and(cantilever\$2)	USPAT; US-PGPUB; JPO	2004/10/21 17:10
	_	· · · · · · · · · · · · · · · · · · ·		

			1	10004/10/01 17 10
-	501	electrostatic and cantilever and RF	USPAT; US-PGPUB;	2004/10/21 17:13
-	18	electrostatic and cantilever and RF) and (varactor	JPO USPAT; US-PGPUB;	2004/10/21 17:35
-	13	361/287 and(varactor)	JPO USPAT; US-PGPUB;	2004/10/22 07:15
-	791	361/\$.ccls. and(cantilever)	JPO USPAT; US-PGPUB;	2004/10/22 07:15
-	4	361/\$.ccls. and(cantilever)) and(actuator near plate	JPO USPAT; US-PGPUB;	2004/10/22 07:16
_	135	361/\$.ccls. and(cantilever)) and(actuator	JPO USPAT; US-PGPUB;	2004/10/22 07:36
_	10	varactor with package and(beam)	JPO USPAT; US-PGPUB;	2004/10/22 07:37
-	3	varactor with package and(cantilever)	JPO USPAT; US-PGPUB;	2004/10/22 07:40
_	66	varactor and(cantilever)	JPO USPAT; US-PGPUB; JPO	2004/10/22 07:51
-	761	varactor and (beam)	USPAT; US-PGPUB; JPO	2004/10/22 07:52
_	42	varactor and(beam)) and(actuator	USPAT; US-PGPUB; JPO	2004/10/22 07:59
-	40	361/277 and (varactor)	USPAT; US-PGPUB; JPO	2004/10/22 08:05
-	6440	varactor	USPAT; US-PGPUB; JPO	2004/10/22 08:05
-	27	varactor.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/22 08:08
-	3	varactor.ti. and(actuator)	USPAT; US-PGPUB; JPO	2004/10/22 08:42
-	30	361/278 and(varactor)	USPAT; US-PGPUB; JPO	2004/10/22 08:49
-	0	microelectrochemical.ti. and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 08:49
-	4	microelectrochemical.ti.	USPAT; US-PGPUB; JPO	2004/10/22 08:50
- .	22	MEMS.ti. and varactor	USPAT; US-PGPUB; JPO	2004/10/22 08:54
-	306	varactor.ti.	USPAT; US-PGPUB; JPO	2004/10/22 09:09
_	37	capacitor.ti. and(cantilever near beam)	USPAT; US-PGPUB; JPO	2004/10/22 09:12
] -	8	<pre>capacitor.ti. and(cantilever near beam)) and(actuator</pre>	USPAT; US-PGPUB; JPO	2004/10/22 09:12
_	73	capacitor.ti. and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 09:12
-	14	<pre>capacitor.ti. and(cantilever)) and(actuator</pre>	USPAT; US-PGPUB; JPO	2004/10/22 09:35

	10	Landin D. L. Colonia de la Col	USPAT;	2004/10/22 09:37
_	19	variable with capacitor.ti.	US-PGPUB;	2004/10/22 09:37
		and(cantilever)	JPO	
		1, 2, 2, 2, 2, 2, 2, 2, 2, 2, 2, 2, 2, 2,	1	2004/10/22 09:46
_	29	variable with capacitor.ti. and(actuator)	USPAT;	2004/10/22 09:46
			US-PGPUB;	
			JPO	
-	344	361/277	USPAT;	2004/10/23 11:17
			US-PGPUB;	
	i		JPO	
-	36	variable with capacitor.ti. and(beam)	USPAT;	2004/10/23 11:19
			US-PGPUB;	
			JPO	
-	19	variable with capacitor.ti.	USPAT;	2004/10/23 11:21
		and(cantilever)	US-PGPUB;	
			JPO	
_	15	361/287 and(cantilever)	USPAT;	2004/10/23 11:25
			US-PGPUB;	
1			JPO	
_	30	361/287 and(actuator)	USPAT;	2004/10/23 12:03
		, , , , , , , , , , , , , , , , , , , ,	US-PGPUB;	
			JPO ,	
_	306	varactor.ti.	USPAT;	2004/10/23 12:08
		varacer.	US-PGPUB;	2001/10/20 12:00
	ļ		JPO	
_	545	variable with capacitor.ti.	USPAT;	2004/10/23 12:23
	313	variable with capacitor.cr.	US-PGPUB;	2004/10/23 12.23
			JPO	
	6	361/279 and (MEMS)	USPAT;	2004/10/23 12:24
	ĺ	301/273 and (MIMO)	US-PGPUB;	2004/10/23 12.24
			JPO	
	4	361/279 and(varactor)	USPAT;	2004/10/23 12:26
_	4	JUL/2/9 and (Valactul)	US-PGPUB;	2004/10/23 12:26
			1	
	2061	MEMC and was grown	JPO	2004/10/23 10:00
-	2861	MEMS and vacuum	USPAT;	2004/10/23 12:26
			US-PGPUB;	
	410	(MDMC)) 1 1 1	JPO	0004/10/00 10 00
_	410	(MEMS and vacuum) and cantilever	USPAT;	2004/10/23 12:29
			US-PGPUB;	
			JPO	